



Newsletter 24 / 2008



EVENTS

SID MEC Spring '08 Meeting March 13-14, 2008, Fraunhofer IOF, Jena, Germany

Special Topics: Microdisplays, Applications, and Optics



The 2008 spring meeting focused on different aspects of microdisplays and their applications.

Basic technology was covered as well as optical components and systems or applications in multimedia and niche markets. 33 paper from 9 countries were presented at the meeting. An industrial exhibition took place during the meeting.

The meeting closed on the second day with a visit to the laboratories of the Fraunhofer IOF.



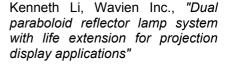
The presentations can be downloaded from the following link:

http://www.iof.fraunhofer.de/sid/program.html

Roland Höfling, Vialux GmbH, "New emerging applications of DLP® microdisplays"

Peter Schreiber, Fraunhofer IOF, "Laser display with single mirror MEMS scanner"

Sergey Kudaev, Fraunhofer IOF, "LED light sources for projection displays"



Dirk Maes, BARCO, "Dual TIR prism, a way to boost the performances of a DLP projector"

Khaled Sarayeddine, Optinvent, "Slim rear projection for laser TV"

Lars Runge, SyproOptics GmbH, "Requirements for projectors for the consumer market"

Mark McCallum, Forth Dimension Displays Ltd., "The use of LCOS microdisplays in 3D optical surface metrology systems"

Stefan Riehemann, Fraunhofer IOF, "Microstructure and 3D-measurement systems with micro-displays"

Sven Krüger, HOLOEYE Systems Inc., "Holographic projection using LCOS displays"

Jan Blochwitz-Nimoth, Novaled AG, "Novaled PIN OLED technology for display applications"

Chris Yates, MicroEmissive Displays, "Some limitations of the conventional 'lifetime' parameter when applied to OLED displays and beginning to develop a real-world equivalent"



One additional highlight of the conference was the evening event, a dinner show in the Zeiss Planetarium including a demonstration of the newest projection technology (all dome laser image projection).









EXHIBITION

12 companies presented displays and components on March 13-14 Most companies came from Germany (8), from Scotland (2), from USA (1) and Norway (1).

BFI OPTILAS GmbH, Puchheim, Germany

CODIXX AG, Barleben, Germany

DFF, German Flat Panel Display Forum, Frankfurt, Germany

Forth Dimension Displays Ltd., Dalgety Bay, Scotland

Fraunhofer IOF, Jena, Germany

HOLOEYE Systems Inc., Westlake Village, CA, USA

Jenoptik Laser, Optik, Systeme GmbH, Jena, Germany

MG Optical Solutions GmbH, Eresing, Germany

MicroEmissive Displays, Edinburgh, Scotland

optonet, Jena, Germany

ViALUX GmbH, Chemnitz, Germany

VISITECH AS, Drammen, Norway

SID-MEC General Meeting



Gerrit Oversluizen (Philips Research) chaired the SID-MEC general meeting, where the status of the chapter was reported, and the election of the officers of the SID-ME chapter for the coming period took place. The present officers volunteered to run for an-

other term, and the proposed candidates were elected unanimously. Therefore the Chapter committee remains composed as follows: Patrick Vandenberghe (Chair), Armin Wedel (Vice-Chair), Herbert De Smet (Secretary), Jutta Rasp (Treasurer).

The ME chapter presently (February 2008) has 508 members. This is 9% less than in February 2007 (559). However, the relative share of ME in the total SID membership (6356) stays more or less constant at 8%. SID-MEC is still the second largest chapter. The chapter has been timely reporting to the SID headquarters and its financial status is very healthy. The main costs are the student award, the newsletter mailing and the bank account fee. This years student award is granted to Lawrence Bogaert (Vrije Universiteit Brussel).

About 120 attendants, including 7 from Japan, 4 from USA, 3 from Belarus, and 1 from Russia and Korea, attended this SID-MEC '08 spring meeting showing that SID-MEC meetings continue to attract a highly international attendance. The upcoming meetings were also

The upcoming meetings were also announced, including the Spring'09 SID-MEC meeting in conjunction with the ITC in Paris, and the Eurosdisplay '09 in Rome (see below).

Student Award

The 2008 SID-MEC student award was given to Lawrence Bogaert (Vrije Universiteit, Brussels) for his work on a "Stereoscopic projection display with LCOS panels and LED light sources".



COMING EVENTS



2009 International Thin Film Transistors Conference ITC'09, March 5-6, 2009, Ecole Polytechnique (near Paris), France

Topics



Thin-Film transistors (TFTs) are key elements for large area electronics, whose applications are increasingly pervading our socities. TFT technology, involving multidisciplinary research topics, has a strong impact in a number of areas including flat panel displays, organic electronics, system on glass, printed electronics and flexible electronics. Due to a strong need for a conference related to TFTs, the International TFT Conference (ITC) was established to exchange ideas and information in the field of organic and inorganic TFTs. The meeting was first held on March 14-15, 2005 at Kyung Hee University in Seoul, South Korea. Since then, the second meeting was held on January 19-20, 2006 in Kitakyushu, Japan, the third on January 25-26, 2007 at the CNR Headquarters, Rome, Italy and the Fourth Conference on January 24-25, 2008 at Kyung Hee University in Seoul. The 5th International Thin Film Transistors Conference (ITC '09) will be held on March 5 and 6, 2009 at Ecole Polytechnique in Palaiseau, Paris neighbourhood, France. ITC '09 will be held jointly with the SID Mid-Europe Chapter Spring Meeting, a yearly meeting attracting

many European display professionals.

Conference Scope

Papers are solicited on the following areas:

LTPS TFTs and related fields

Organic TFTs and related fields

Amorphous silicon TFTs and related fields

Nanowires and nanotubes TFTs and related fields

TFT circuits and related fields

Display and other systems based on TFTs

AM backplane for AMOLED & Flexible Displays

TFTs on flexible substrate

Key Dates

Submission of Short Abstract

December 15, 2008

Acceptance Notification

January 1, 2009

Submission of camera ready manuscript

February 1, 2009

ITC'09 secretariat

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Fax: +33 1 69 33 43 30

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Website:

www.lpicm.polytechnique.fr/itc09/



Eurodisplay 2009 (International Display Research Conference 2009) September 14-17, 2009, Rome, Italy

The next Eurodisplay Conference will be held in Rome in September 2009. SID Mid-Europe Chapter is responsible for the arrangements and the organization of the conference is headed by SID-MEC veterans. The General Chair is Mr. Jvrki Kimmel from Nokia in Finland, the Program Chair is Prof. Norbert Frühauf from University of Stuttgart, Germany, the Workshop Chair is Dr. Gerrit Oversluizen from Philips in the Netherlands, the Exhibit and Sponsorship Chair is Ms. Jutta Rasp from FP Displays in Germany, and the local organizing Chair is Dr. Guglielmo Fortunato from the CNR in Italy. We are looking for a great conference and a worldwide participation in one of the great centres of European culture. If you or your company have an interest in sponsoring Eurodisplay 2009, please contact either Jyrki Kimmel or Jutta Rasp. Contact details inside this Newslet-

NEWS

Several entities from the SID-Mid Europe chapter area together with partners from Europe are participating in the new European Framework 7 project OLAtronics. The objective of OLAtronics is the development and integration of processes & technologies for the production of organic large-area flexible electronics. Project duration is from January 1st, 2008 to

Dec 31st, 2010. The Project Consortium consists of 8 partners of 5 EU Countries and USA. It is coordinated by Aristotle University of Thessaloniki (AUTh) - LTFN, Greece. OLAtronics will significantly enhance the existing capabilities on the synthesis, preparation, encapsulation and quality control techniques for the development of nanostructured active and passive materials with advanced physical properties. The effectiveness and robustness of the manufacturing processes, and the efficient material encapsulation will be combined with the accurate measurement of the materials optical response, microstructure and morphology by in-situ and real-time optical sensing techniques equipped with advanced analysis & modeling capabilities for the achievement of high performance materials components. These will be used initially for specific FED applications (such as EC displays and OPVs) but ultimately they will be extended to several applications, for example flexible OLED for display and lighting, epaper, sensors, organic circuits, smart systems on tags, signage, low-cost RFID, etc.

Call for SID-ME Chapter Student Award 2009

The SID-ME Chapter Student Award is given for an outstanding scientific or technical achievement in, or contribution to, research on information display. The applicant is a student at a university/institute in the SID-ME region. The award



amounts to 1500 Euro, with the obligation to present the contribution at the SID-MEC meeting where the award is presented. The conference fee is waived. The applicant must be a member of SID. For information on student membership, see below. The application deadline is January 31, 2009.

Application for SID-ME Chapter Student Award must be include following details: Name, SID Membership No., Institute/University, Address, Title of contribution, Abstract (100-150 words), References (SID-ME member).

The application should be submitted to the award committee consisting of Prof. Dr.-Ing. N. Frühauf, Dr. G. Oversluizen and Prof. Dr. H. De Smet.

SID Student Membership: At http://www.sid.org you find information on SID student membership. Note the favourable offer of \$5.00 per year for student members.

SID-ME CHAPTER COMMITTEE

The SID-ME Chapter committee is now formed by:

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Additional members of the SID-ME Chapter committee are:

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SID PAYMENT

The SID annual membership fee amounts US\$ 75. Please note that the membership is a rolling membership, which means that it runs for 12 months from the month in which the payment was made. For more information, see the SID website www.sid.org.

We encourage our members to pay directly to SID-HQ in the USA, but if they want to pay to the ME-Chapter directly the annual fee should be EUR 70 with all bank fees covered by the member!

Account number:

0233-826729.60H

At: UBS, Aeschenplatz 6, CH-4052 Basel

BIC: UBSWCHZH80A

IBAN: CH760023323382672960H

Account name: The Soc. f. Inform. Display, SID-ME c/o Jutta Rasp

Please indicate your name on the remittance papers.



THE NEWSLETTER

If you want to place an article in the Newsletter, which is interesting

for the European Display Society, please send it to: armin.wedel@iap.fraunhofer.de